

EXPEDITED PROCEDURE – EXAMINING GROUP 2822

S/N 10/623,788

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | | |
|-------------|--|-----------------|-------------------|
| Applicant: | Leonard Forbes et al. | Examiner: | Pamela E. Perkins |
| Serial No.: | 10/623,788 | Group Art Unit: | 2822 |
| Filed: | July 21, 2003 | Docket No.: | 1303.109US1 |
| Title: | STRAINED SEMICONDUCTOR BY FULL WAFER BONDING | | |

AMENDMENT & RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action dated March 29, 2007, please amend the application as follows: